



S/N 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Trung T. Doan	Examiner:	Sylvia MacArthur
Serial No.:	09/652,713	Group Art Unit:	1763
Filed:	August 31, 2000	Docket No:	303.928US5
Title	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING		

PETITION FOR A ONE-MONTH EXTENSION OF TIME

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a one-month extension of time be granted in which to respond to the Final Office Action mailed May 16, 2006, said period of response being extended from August 16, 2006 to September 16, 2006.

Please charge Deposit Account No. 19-0743 in the amount of \$120.00 to cover the required extension fee. Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.

09/15/2006 HLE333 00000070 190743 09652713

02 FC:1251 120.00 DA

Respectfully Submitted

TRUNG T. DOAN


By his Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
P.O. Box 2938
Minneapolis, MN 55402
(612) 349-9587

Date:

11 Sept '06

By:


Timothy B. Clise
Reg. No: 40,957

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 11 day of September 2006.

Name: Kate Cannon

Signature: 